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(57) Abstract :
ABSTRACT: Title: Metal-Free Hydrogen Sensor and Method of Fabrication Thereof The present disclosure proposes a metal-free hydrogen sensor. The metal-free hydrogen sensor 100 comprises a thin film 102 and an interdigitated electrode 104. The proposed cost effective hydrogen gas sensor is simple, environmental friendly and feasible for mass production. The proposed polyvinyl based hydrogen sensor does not require any precious metal doping. The proposed metal-free hydrogen gas sensor fabricated does not involve usage of toxic chemicals or release of harmful gases. The proposed polyvinyl based hydrogen gas sensor is easily fabricated and provides good stability and precision.

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